

| METAL UNDERCOATING | INITIAL STRENGTH | TEMPERATURE ENVIRONMENT | HUMIDITY ENVIRONMENT | GOLD PLATING (CYANIDE GOLD PLATING SOLUTION) | ETCHING | REMARKS |
|--------------------|------------------|-------------------------|----------------------|--|---------|--|
| Cu | ○ | × | × | × | ○ | |
| NiCr-BASED METAL | ○ | × | × | × | ○ | |
| NiV-BASED METAL | ○ | × | × | × | ○ | |
| Cr-BASED METAL | ○ | △ | △ | ○ | × | SPECIAL ETCHING ENVIRONMENT LOAD PRODUCTION OF HEXAVALENT CHROMIUM |

FIG.1

FIG.2A

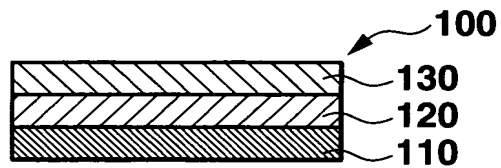


FIG.2B

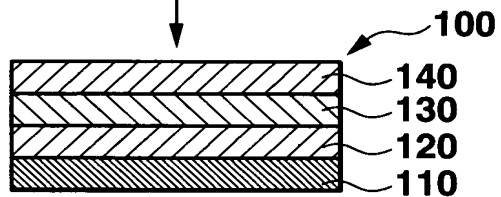


FIG.2C

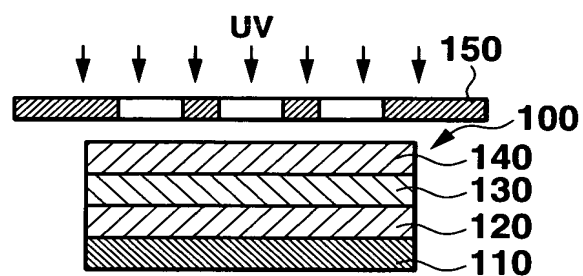


FIG.2D

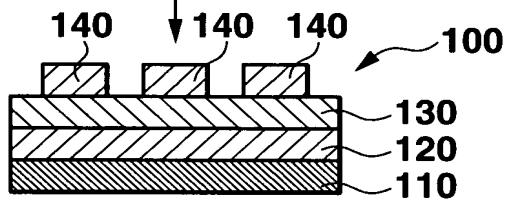


FIG.2E

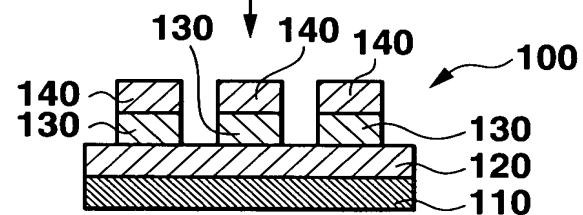


FIG.2F

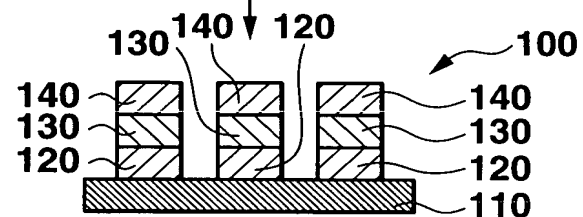


FIG.2G

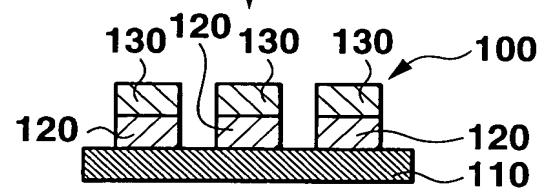


FIG.3A

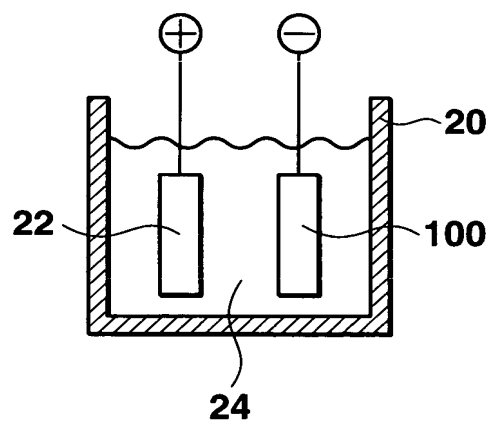


FIG.3B

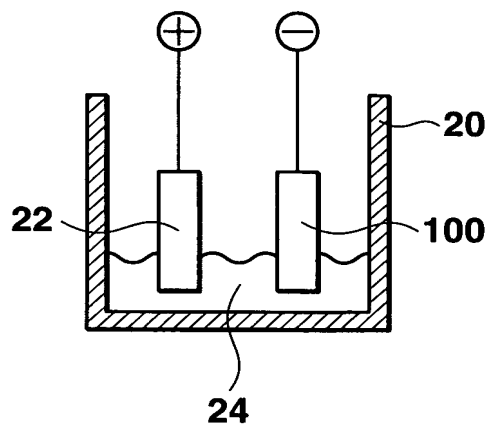
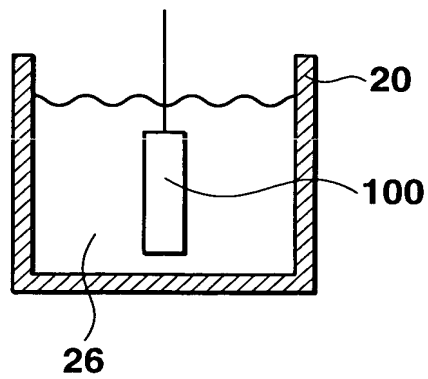


FIG.3C



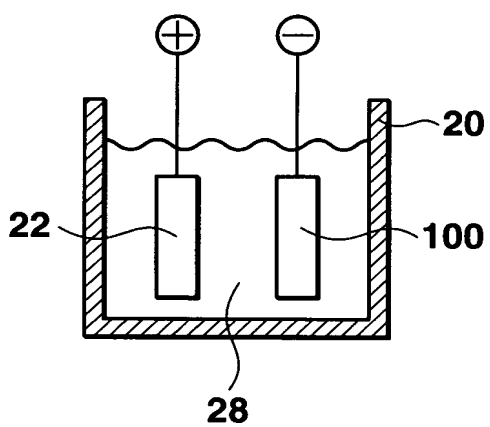


FIG.4

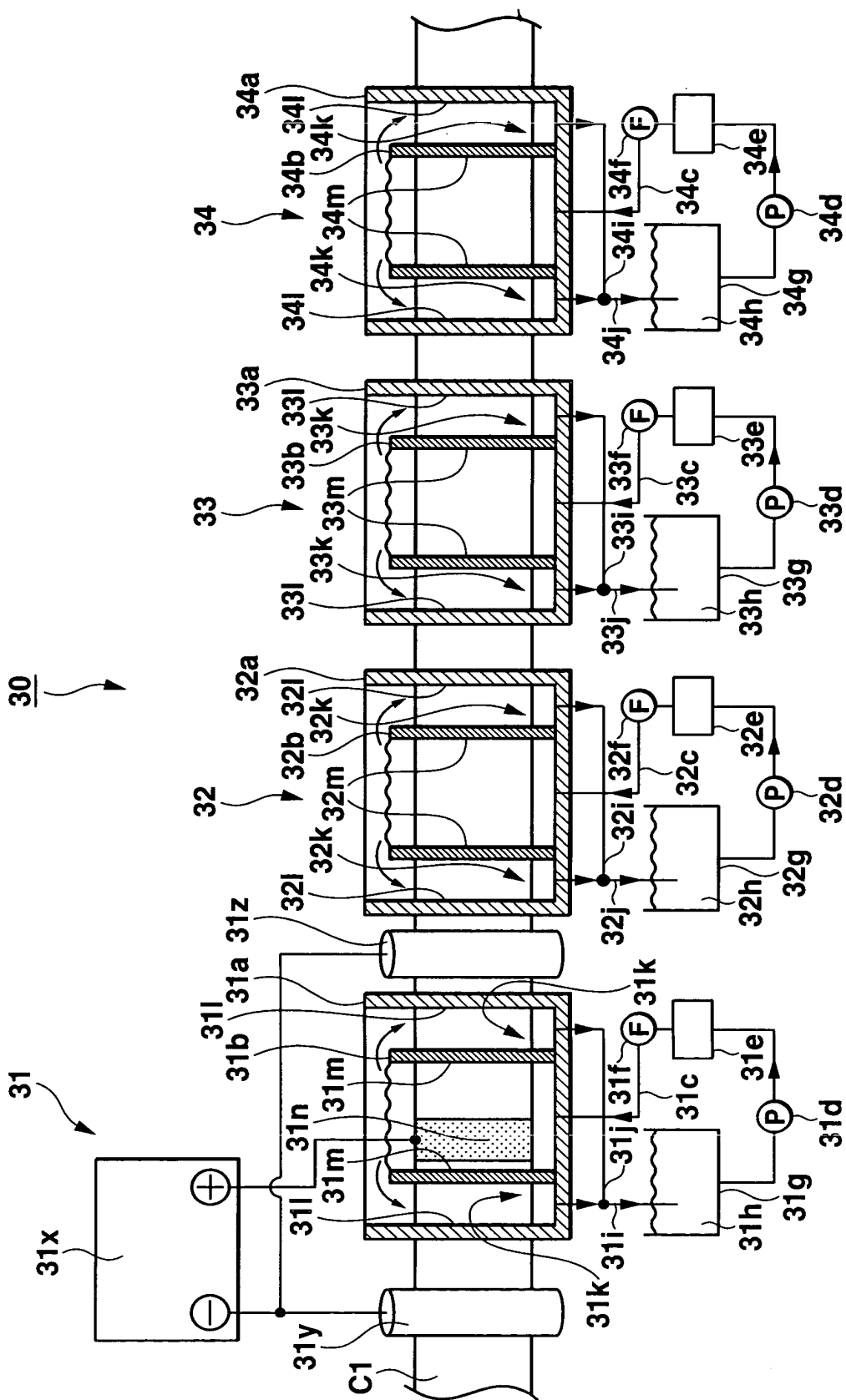


FIG.5

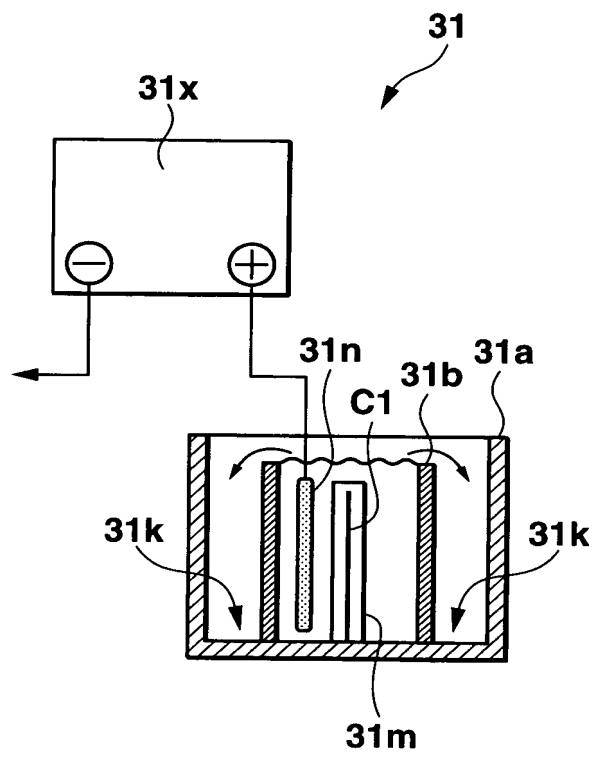


FIG.6

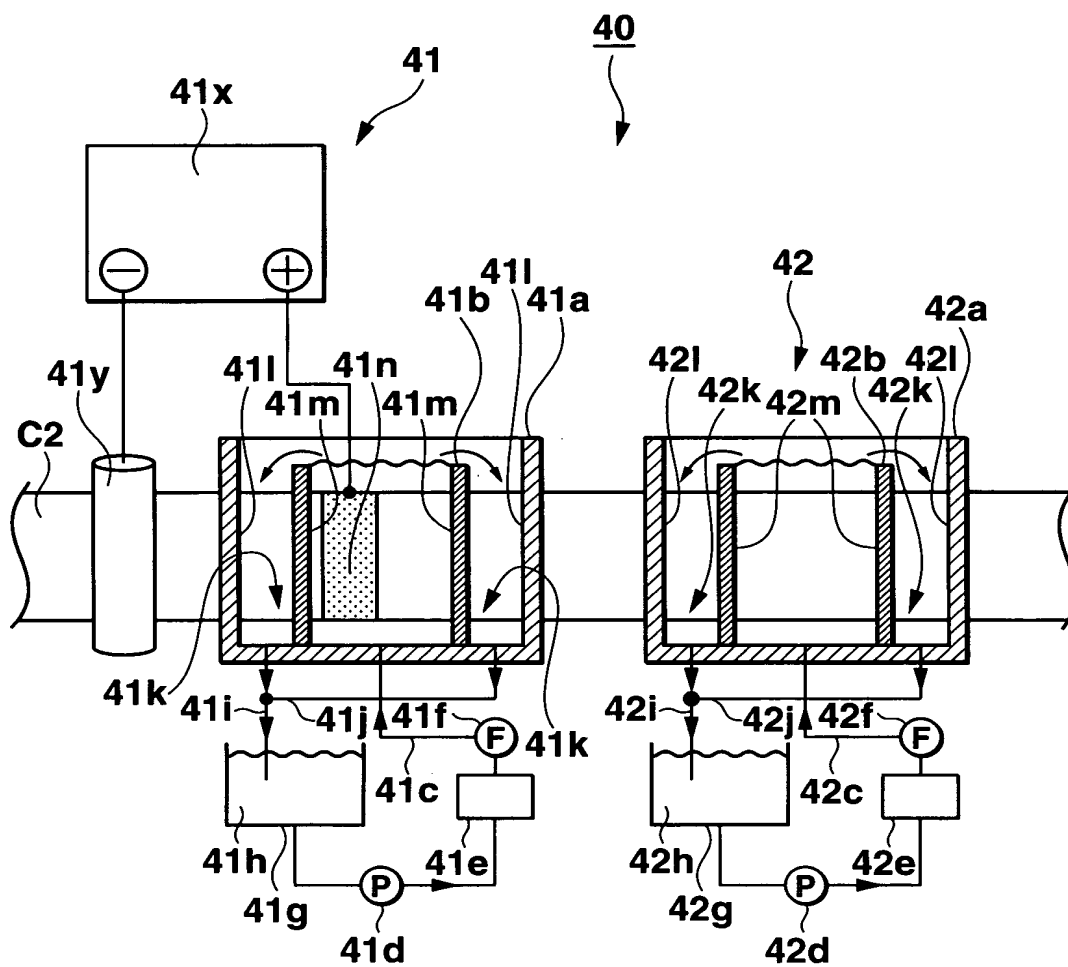


FIG.7

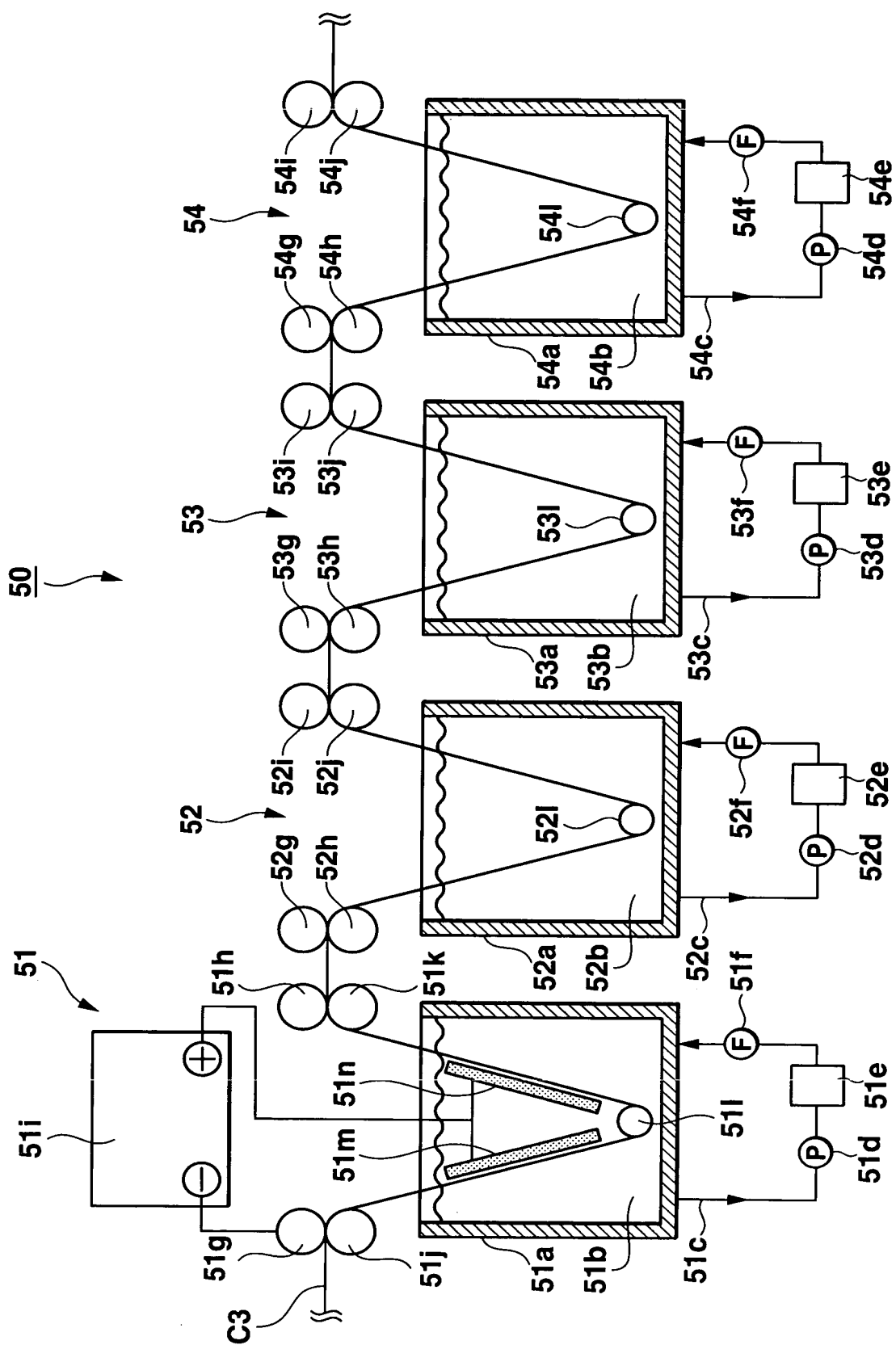


FIG.8

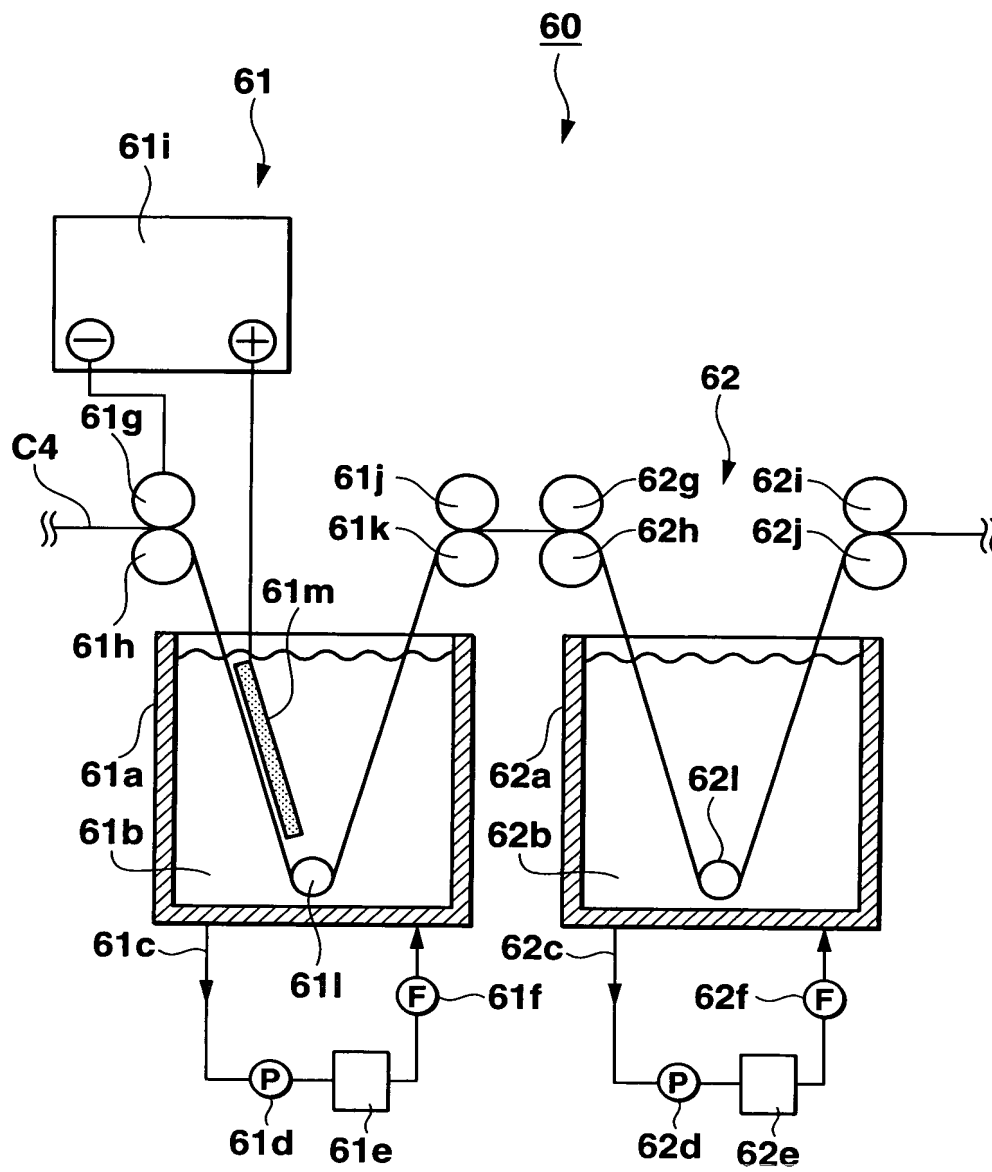


FIG.9

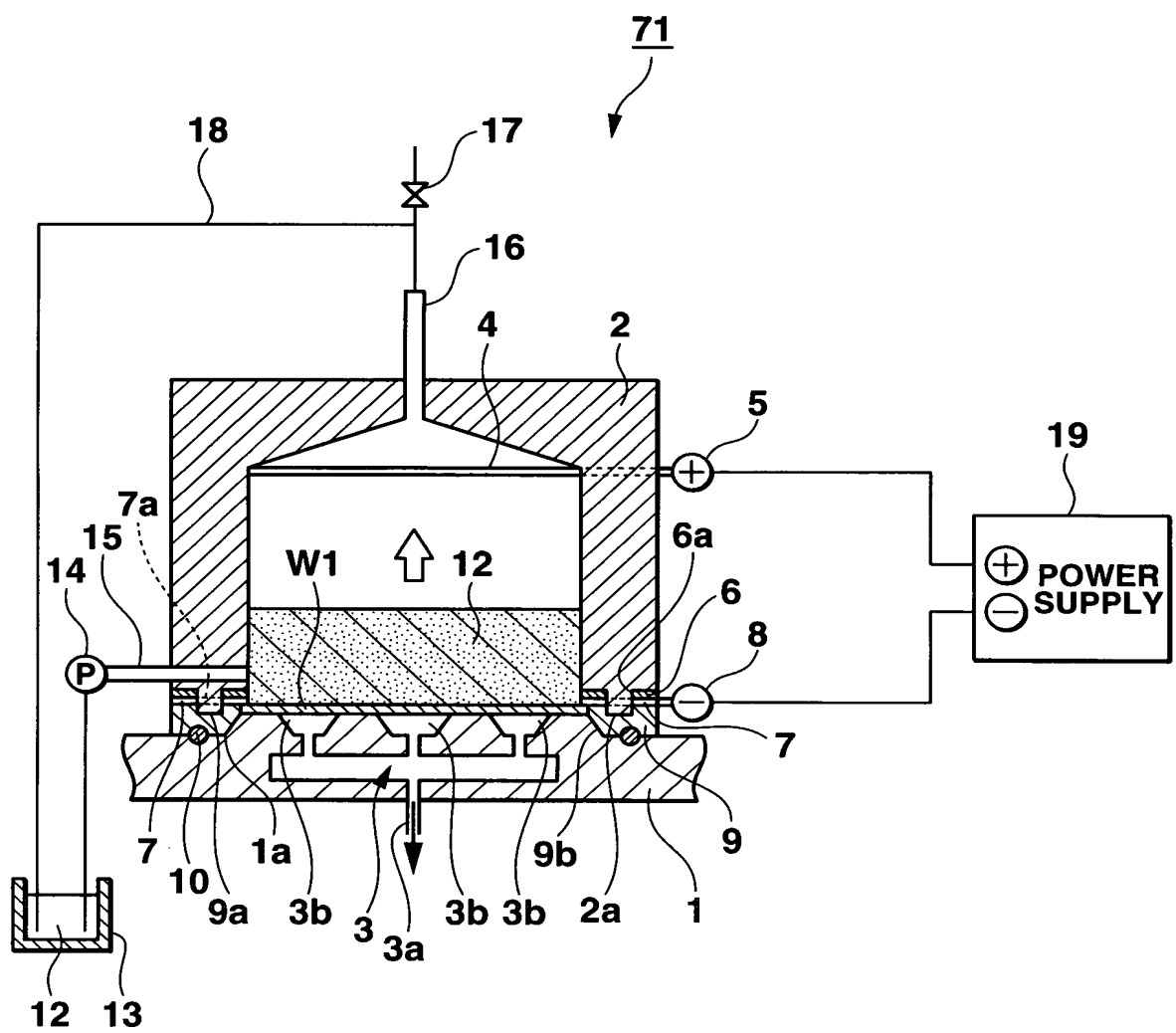


FIG.10

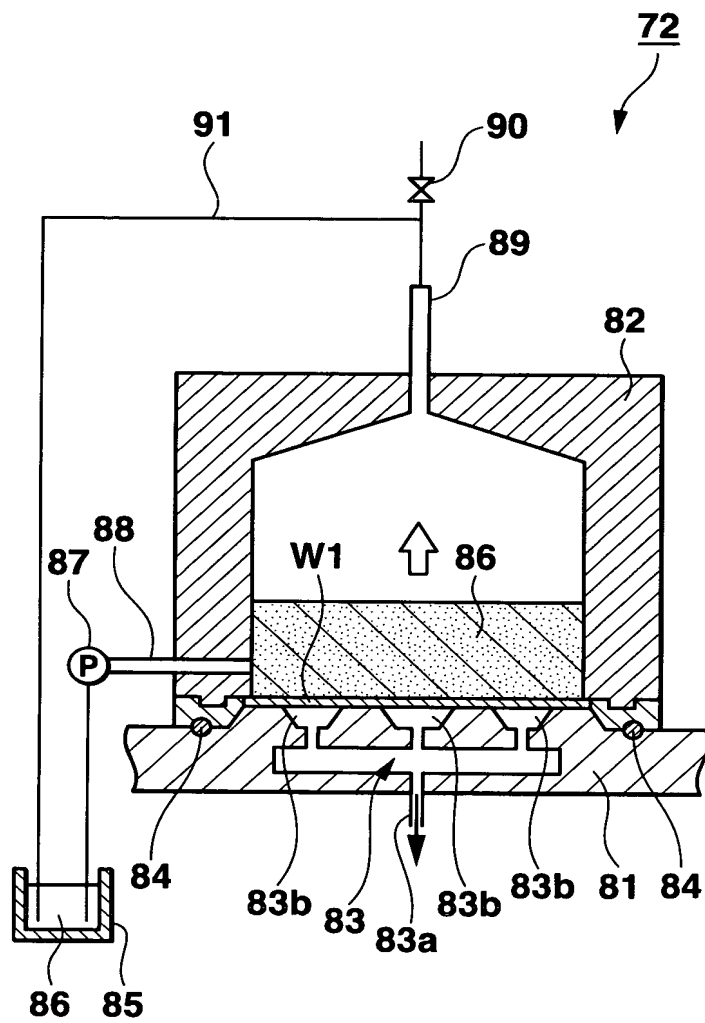


FIG.11

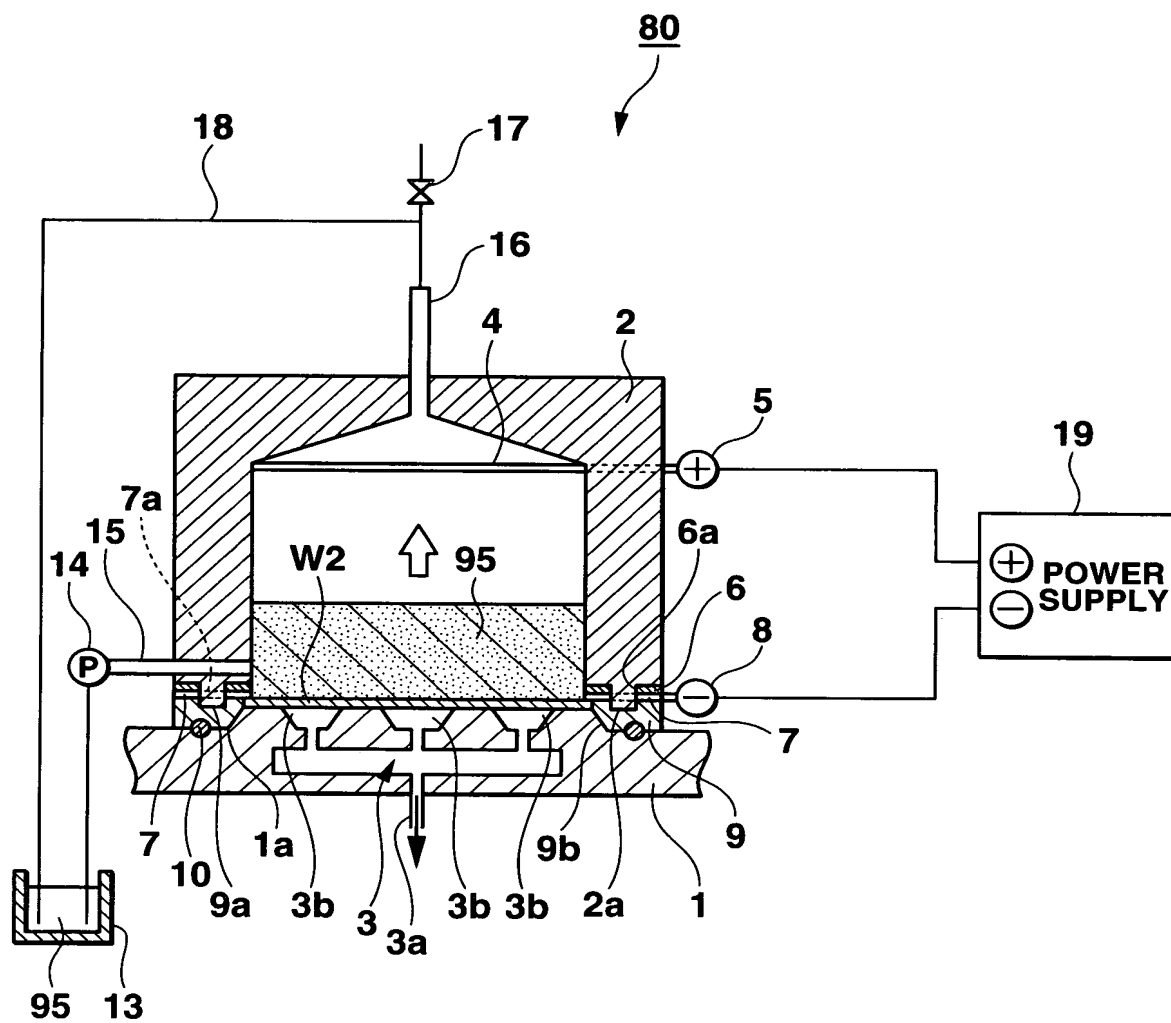


FIG.12

| FORM | EXPERIMENT No. | PROPERTIES OF TREATMENT SOLUTION | NAMES OF TREATMENT SOLUTIONS | TREATMENT METHODS | TREATMENT SOLUTION CONCENTRATION (vol%) | ADDITIVE (REDUCING AGENT) CONCENTRATION (vol%) | CURRENT DENSITY (A/dm ²) | TEMPERATURE (°C) | TIME (sec) | Cu PEELING | Cr PEELING |
|------------------|----------------|----------------------------------|---|------------------------------------|---|--|--------------------------------------|------------------|------------|------------|------------|
| SIMULTANEOUS (A) | 1 | ALKALINE | A-PROCESS (MANUFACTURED BY MELTEX K.K.) | DIP | 100 | ... | ... | 50 | 25 | ○ | × |
| | | | | | | | | | 30 | ○ | × |
| | | | | | | | | | 90 | ○ | × |
| INDIVIDUAL (B) | 2 | ACIDIC | CUPRIC CHLORIDE HYDROCHLORIC ACID | DIP | 20~40 | ... | ... | 30 | 80 | × | × |
| | | | | | | | | | 85 | ○ | × |
| | 3 | ACIDIC | SAS (MANUFACTURED BY K.K. MURATA) | DIP | 50 | ... | ... | 30 | | ... | × |
| | | | | | | | | | | ... | × |
| | | | | | | | | | 30 | ... | × |
| | | | | | | | | | 40 | ... | × |
| | 4 | ALKALINE | DSL-100 (MANUFACTURED BY K.K. MURATA) | ANODE ELECTROLYSIS OXIDATION | 20 | ... | 5 | 50 | 20 | ... | × |
| | | | | | | | | | 30 | ... | × |
| | 5 | ACIDIC | SAS (MANUFACTURED BY K.K. MURATA) | CATHODE ELECTROLYSIS REDUCTION | 50 | ... | 5 | 30 | 10 | ... | × |
| | | | | | | | | | 60 | ... | × |
| | 6 | ACIDIC | SAS (MANUFACTURED BY K.K. MURATA) | CATHODE ELECTROLYSIS REDUCTION | 50 | ... | 5 | 30 | 10 | ... | × |
| | 7 | ACIDIC | SAS (MANUFACTURED BY K.K. MURATA) | CATHODE ELECTROLYSIS REDUCTION+DIP | 50/50 | ... | 5/ | 30/30 | 2/8 | ... | ○ |
| | | | | | | | | | 5/8 | ... | ○ |
| | 8 | ACIDIC+ REDUCING AGENT | SAS (MANUFACTURED BY K.K. MURATA) +SODIUM BISULFITE | DIP | 50 | 0.1 | ... | 30 | | ... | × |
| | | | | | | 0.25 | | | | ... | × |
| | | | | | | 0.5 | | | 30 | ... | × |
| | | | | | | 1 | | | | ... | × |

FIG.13

| EXPERIMENT No. | PARAMETERS | SAS CATHODE ELECTROLYSIS REDUCTION TREATMENT CONDITIONS | | | | SAS DIP TREATMENT CONDITIONS | | | Cr PEELING |
|----------------|---|---|--------------------------------------|------------------|------------|------------------------------|------------------|------------|------------|
| | | CONCENTRATION (vol%) | CURRENT DENSITY (A/dm ²) | TEMPERATURE (°C) | TIME (sec) | CONCENTRATION (vol%) | TEMPERATURE (°C) | TIME (sec) | |
| 1 | CURRENT DENSITY | 50 | 1 | 30 | 2 | 50 | 30 | 17 | ○ |
| 2 | | | 5 | | | | | 10 | |
| 3 | SAS CONCENTRATION IN DIP TREATMENT | 50 | 1 | 30 | 2 | 5 | 30 | 22 | ○ |
| 4 | | | | | | 10 | | 20 | |
| 5 | | | | | | 20 | | 20 | |
| 6 | SAS CONCENTRATION IN CATHODE ELECTROLYSIS REDUCTION TREATMENT | 5 | 1 | 30 | 2 | 5 | 30 | 25 | ○ |
| 7 | | 10 | | | | 10 | | 20 | |
| 8 | | 20 | | | | 20 | | 20 | |

FIG.14

| EXPERIMENT No. | TREATMENT METHODS | NaCl SOLUTION CATHODE ELECTROLYSIS REDUCTION TREATMENT CONDITIONS | | | | SAS DIP TREATMENT CONDITIONS | | | Cr PEELING |
|-------------------|---|--|--|---------------------|---------------|------------------------------|---------------------|---------------|---------------|
| | | CONCENTRATION (wt%) | CURRENT DENSITY (A/dm ²) | TEMPERATURE (°C) | TIME (sec) | CONCENTRATION (vol%) | TEMPERATURE (°C) | TIME (sec) | |
| 1 | CATHODE ELECTROLYSIS REDUCTION USING NaCl SOLUTION | 25 | 1 | 30 | 150 | • • • | • • • | • • • | × |
| 2 | CATHODE ELECTROLYSIS REDUCTION USING NaCl SOLUTION+ DIP USING SAS | 25 | 1 | 30 | 2 | 50 | 30 | 25 | ○ |

FIG.15

| EXPERIMENT No. | CATHODE ELECTROLYSIS REDUCTION TREATMENT SOLUTION | DIP TREATMENT SOLUTION | Cr PEELING |
|-------------------|--|-------------------------------|---------------|
| 1 | NaCl (2N) (pH=5.1) | SAS | ○ |
| 2 | NaCl (2N)+NaOH (pH=7.0) | SAS | ○ |
| 3 | NaCl (2N)+NaOH (pH=9.0) | SAS | ○ |
| 4 | NaCl (2N)+NaOH (pH=10.0) | SAS | ○ |
| CONDITIONS | TEMPERATURE: ROOM TEMPERATURE | TEMPERATURE: ROOM TEMPERATURE | |
| | TIME: 30sec | TIME: 300sec | |
| | CD: 1A/dm ² | CONCENTRATION: 50% | |
| | ANODE: Pt | | |

FIG.16

| TREATMENT SOLUTION | HYDROCHLORIC ACID | | SULFURIC ACID | | NaCl SOLUTION | |
|---------------------|-------------------|--------------|---------------|----------|---------------|--------------|
| DIP TIME (sec) | 1 | 5 | 1 | 5 | 1 | 5 |
| CHROMIUM (D) | DETECTED | DETECTED | DETECTED | DETECTED | DETECTED | DETECTED |
| HEXAVALENT CHROMIUM | NOT DETECTED | NOT DETECTED | DETECTED | DETECTED | NOT DETECTED | NOT DETECTED |

FIG.17